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#44

Applicant: Yasuaki Tsuzuki et al.

Serial No. 09/361,980

Filed: July 28, 1999

For: METHOD OF ETCHING METALLIC THIN FILM  
RESISTOR

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DECISION ON PETITION  
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This is a decision on the petition filed on May 2, 2002 under 37 C.F.R. 1.48(b) requesting that the inventorship of this application be corrected by deleting ICHIRO ITO, SATOSHI SHIRAKI, TOMIO YAMAMOTO, MAKOTO OHKAWA, and ATSUMI TAKAHASHI. Petitioner has met the requirements of 37 C.F.R. 1.48(b).

The petition is **GRANTED**.

A handwritten signature in cursive script, likely belonging to Benjamin L. Utech.

Benjamin L. Utech  
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